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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10785617
	Filing Date		2004-02-23
	First Named Inventor	Look	
	Art Unit	2613	
	Examiner Name	Wai Lun Leung	
	Attorney Docket Number	8433P008	

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	1	6771908		2004-08-03	van Eijk et al.	
	2	6898376		2005-05-24	Gerstel et al.	
	3	6556319		2003-04-29	Feinberg et al.	
	4	6307653		2001-10-23	Bala et al.	
	5	6477288		2002-11-05	Sato	
	6	7242860		2007-07-10	Ikeda et al.	
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6	Office Action mailed 3 November 2009 for United States Patent Application No. 10/785,618, filed 23 February 2004, 14 pages.	<input type="checkbox"/>
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